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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

SHRINIVASAN et al.

Application No. 10/007,227

Filed: November 7, 2001

For: METHOD AND APPARATUS FOR
SEALING SUBSTRATE LOAD PORT IN A
HIGH PRESSURE REACTOR

Group Art Unit: 1756

Examiner:

Atty. Docket No. NOVEP012

Date: July 26, 2002

COPY OF DOCUMENT
ORIGINALLY FILED

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, DC 20231 on July 26, 2002.

Signed:

Melinda M. Ward

INFORMATION DISCLOSURE STATEMENT

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Commissioner for Patents
Washington, DC 20231

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TC 1700

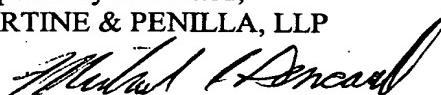
Dear Sir:

The reference listed in the attached PTO Form 1449, a copy of which is attached, may be material to examination of the above-identified patent application. Applicants submit this reference in compliance with their duty of disclosure pursuant to 37 CFR §§ 1.56 and 1.97. The Examiner is requested to consider this reference and to acknowledge such consideration by initialing the appropriate location on the attached PTO Form 1449.

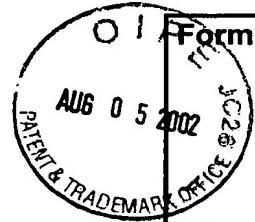
This Information Disclosure Statement (IDS) is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that this reference indeed constitutes prior art.

This IDS is believed to be filed before the mailing date of a first Office Action on the merits. Accordingly, it is believed that no fees are due in connection with the filing of this IDS. However, if it is determined that any fees are due, then the Commissioner is hereby authorized to charge such fees to Deposit Account 50-0805 (Order No. NOVEP012).

Respectfully submitted,
MARTINE & PENILLA, LLP


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Form 1449 (Modified)
**Information Disclosure
Statement By Applicant**

(Use Several Sheets if Necessary)

Atty Docket No: U.S.

NOVEP012

Applicants:

SHRINIVASAN et al.

Filing Date: Group:

November 7, 2001

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U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class
A						
B						
C						
D						
E						
F						
G						
H						
I						
J						
K						

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Foreign Patent or Published Foreign Patent Application

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub-class	Translation
							Yes
L	WO01/55628A1	8/02/01	WIPO				X
M							
N							
O							
P							

Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
R		
S		
T		
Examiner		Date Considered

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered.
 Include copy of this form with next communication to applicant.